

Notice of References Cited	Application/Control No. 10/706,460		Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Hai L. Nguyen		Art Unit 2816	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
X	A	US-6,369,994	04-2002	Voldman, Steven H.	361/56
X	B	US-6,034,854	03-2000	Suga, Koichiro	361/56
X	C	US-5,914,516	06-1999	Konno, Hideki	257/357
X	D	US-5,491,441	02-1996	Goetschel et al.	327/291
X	E	US-4,906,871	03-1990	Iida, Tetsuya	326/66
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.